

SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD

ABSTRACT

A load lock module includes: stage regions arranged around a center position; a rotary support including fixed support pins for supporting the substrates; and a drive mechanism for driving the rotary support in a rotational direction. When transferring the substrates between the load lock module and the first or second transfer module, the first or second transfer robot transfers the substrates with respect to the fixed support pins.

(Fig. 6)